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CONFIRMATION NO. 5813

SERIAL NUMBER 10/593,857	FILING or 371(c) DATE 09/22/2006 RULE	CLASS 156	GROUP ART UNIT 1792	ATTORNEY DOCKET NO. 58409/N305		
APPLICANTS Nam Hun Kim, Suwon-si, KOREA, REPUBLIC OF; ** CONTINUING DATA ***** This application is a 371 of PCT/KR05/00860 03/24/2005 ** FOREIGN APPLICATIONS ***** REPUBLIC OF KOREA 10-2004-0020321 03/25/2004 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** ** SMALL ENTITY ** 06/18/2007						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/DUY NGUYEN DEO/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWINGS 4	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 4
ADDRESS CHRISTIE, PARKER & HALE, LLP PO BOX 7068 PASADENA, CA 91109-7068 UNITED STATES						
TITLE Plasma Chamber Having Plasma Source Coil and Method for Etching the Wafer Using the Same						
FILING FEE RECEIVED 550	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			